

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

O I P E
AUG 18 2003
U.S. PATENT & TRADEMARK OFFICE
In Re Patent Application of:)
Liu et al.) Examiner: Sanghavi, H.
Application No. 09/819,520) Art Unit: 2874
Filed: March 27, 2001)
For: METHOD AND APPARATUS FOR)
INTERLEAVING AND SWITCHING)
AN OPTICAL BEAM IN A)
SEMICONDUCTOR SUBSTRATE)

Mail Stop RCE
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INFORMATION DISCLOSURE STATEMENT

Sir/Madam:

Enclosed is a copy of Information Disclosure Citation Form PTO-1449 together with copies of the documents cited on that form. It is respectfully requested that the cited documents be considered and that the enclosed copy of Information Disclosure Citation Form PTO-1449 be initialed by the Examiner to indicate such consideration and a copy thereof returned to applicant(s).

Pursuant to 37 C.F.R. § 1.97, the submission of this Information Disclosure Statement is not to be construed as a representation that a search has been made and is not to be construed as an admission that the information cited in this statement is material to patentability.

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If there are any additional charges, please charge Deposit Account No. 02-2666.

Respectfully submitted,

BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN LLP

Dated: 8-15-03



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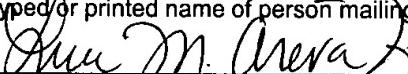
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**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(use as many sheets as necessary)

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<i>Complete if Known</i>	
Application Number	09/819,520
Filing Date	March 27, 2001
First Named Inventor:	Liu et al.
Group Art Unit	2874
Examiner Name	Sanghavi, H.
Attorney Docket Number	42P11003

FOREIGN PATENT DOCUMENTS

Examiner Signature		Date Considered	
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***EXAMINER:** Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Unique citation designation number. ²See attached Kinds of U.S. Patent Documents. ³Enter Office that issued the document, by the two-letter code (WIPO Standard S.3). ⁴For Japanese patent documents, the indication of the year of reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶Applicant is to place a check mark here if English language Translation is attached.

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